



Docket No. 740756-2296

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Hisashi OHTANI et al.) Group Art Unit: 2815
Serial No. 09/837,552) Examiner: N. Drew Richards
Filed: April 19, 2001) Confirmation No. 7555
For: SEMICONDUCTOR DEVICE AND) Date: November 5, 2003
MANUFACTURING METHOD
THEREOF

**REQUEST FOR ACKNOWLEDGEMENT OF
INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Information Disclosure Statements with Forms PTO-1449 was filed in the above-identified patent application on July 14, 2003. Applicants have not yet received back from the Examiner a copy of the Forms PTO-1449 initialed to acknowledge the fact that the Examiner has considered the cited disclosed information.

The Examiner is requested to initial and return to the undersigned a copy of the subject Forms PTO-1449.

Should there be any questions concerning this communication, please telephone the undersigned at the number set forth below.

Respectfully submitted,


Jeffrey L. Costellia
Registration No. 35,483

NIXON PEABODY LLP
Suite 900
401 9th Street, N.W.
Washington, D.C. 20004-2128
(202) 585-8000
NVA281236.1

Match and Return